



FORM PTO-1449 U.S. DEPARTMENT OF COMMERCE PATENT AND TRADEMARK OFFICE			ATTY. DOCKET NO. 702-002116	SERIAL NO. 09/719,757
INFORMATION DISCLOSURE STATEMENT STATEMENT BY APPLICANT			APPLICANTS Dirk E.M. VAN DYCK et al.	
(Use several sheets if necessary)			FILING DATE July 16, 2001	GROUP ART UNIT-not yet assigned

### U.S. PATENT DOCUMENTS

EXAMINER INITIAL		DOCUMENT NUMBER					DATE	NAME	CLASS	SUBCLASS	FILING DATE IF APPROPRIATE
	AA										
	AB										
	AC										
	AD										
	AE										
	AF										
	AG										
	AH										
	AI										
	AJ										
	AK										

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### FOREIGN PATENT DOCUMENTS

		DOCUMENT NUMBER						DATE	COUNTRY	CLASS	SUBCLASS	TRANSLATION		
												YES	NO	
	AL													
	AM													
	AN													
	AO													
	AP													

### OTHER DOCUMENTS (Including Author, Title, Date, Pertinent Pages, Etc.)

	AQ		Jedrasik, P. et al. "Optimal filtering versus regularization methods in the Fourier precompensation based proximity neurocorrection in electron beam lithography," <i>Microelectronic Eng.</i> 41-42: 195-198 (1998)
	AR		Jedrasik P. "Neural networks application for fast, direct correction kernel generation for proximity effects correction in electron beam lithography," <i>Microelectronic Eng.</i> 27(1-4): 191-194 (1995)
	AS		Frye, R.C. "Adaptive neural network algorithms for computing proximity effect corrections," <i>J Vacuum Sci &amp; Tech (Part B)</i> 9(6): 3054-3058 (1991)

EXAMINER



DATE CONSIDERED

7/22/04

EXAMINER: Initial if citation considered, whether or not citation is in conformance with MPEP 609; Draw line through citation if not in conformance and not considered. Include copy of this form with next communication to applicant.